

IN THE SPECIFICATION

On page 2 first line please insert -- This is a Divisional Application of Serial No.: 10/305,684 filed November 26, 2002, which is presently pending. --

IN THE CLAIMS

Please cancel claims 1-26 without prejudice.

Please amend the following claim:

34. (Currently Amended) The method device of claim 27, wherein said forming one or more sacrificial layers comprises heating the silicon wafer while in the vicinity of one or more gaseous materials.

If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

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